

MAY 12 2004

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OFFICIAL  
PATENT

Docket No. 150.00810102

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Brian A. Vaartstra ) Group Art Unit: 2823  
Serial No.: 09/865,612 )  
Confirmation No.: 4697 )  
Filed: May 25, 2001 )  
For: METHODS, COMPLEXES, AND SYSTEMS FOR FORMING METAL-CONTAINING FILMS ON SEMICONDUCTOR STRUCTURES

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Applicant(s):	Brian A. Vaartstra	)	Group Art Unit:	2823
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Serial No.:	09/865,612	)	Examiner:	George Fourson III
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RESPONSE TO EX PARTE QUAYLE ACTION

Assistant Commissioner for Patents  
Mail Stop Amendment  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

An *Ex Parte Quayle* Action dated 5 May 2004 was received in the above-referenced matter. In response, please replace the "Amendments to the Claims" section of the 20 October 2003 Amendment and Response (filed in this application) with the "Amendments to the Claims" section provided below.

The following "Amendment to the Claims" section is identical to that filed on 20 October 2003 with the exception that the claim identifiers indicating the status of claims 1-17 of the application have been inserted to comply with current rules.

Amendments to the Claims are reflected in the listing of claims which begins on the page entitled "Amendments to the Claims."

Remarks begin on the page entitled "Remarks."